

Attorney's Docket No.: 07977-017002
Client's Ref. No.: US2968C1D1

OFFICIAL COMMUNICATION**FACSIMILE**

FOR THE PERSONAL ATTENTION OF:
EXAMINER LAURA SCHILLINGER

GROUP 2813 FAX NO: 1-703-872-9319

Number of pages including this page 8

Applicant : Yamazaki, et al.
Serial No. : 09/451,665
Filed : November 30, 1999

Art Unit : 2813
Examiner : Laura Schillinger
Confirmation No. : 9359

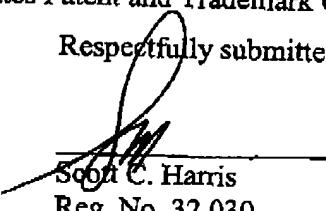
Title : SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached to this facsimile communication cover sheet is an Amendment, faxed this 23rd day of September, 2002, to Group 2813, the United States Patent and Trademark Office.

Respectfully submitted,


Scott C. Harris
Reg. No. 32,030

Date: September 23, 2002

SCH/SMR

PTO Customer No. 20985



Fish & Richardson P.C.
4350 La Jolla Village Drive, Suite 500
San Diego, California 92122
Telephone: (858) 678-5070
Fax: (858) 678-5099

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Attorney's Docket No.: 07977/017002/US2968C1p1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Commissioner for Patents
 Washington, D.C. 20231

9/24/02
 10/15/02

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September 23, 2002
 [Note: September 21, 2002
 was a Saturday]

AMENDMENT

In response to the Official Action dated May 21, 2002,
 Paper No. 12, in the above-referenced application, kindly amend
 the above-identified application as follows.

ENTER

In the Claims:

Please amend the claims as follows.

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DO NOT SUBMIT
 1. (Amended) A method of manufacturing a semiconductor device
 comprising the steps of:
 forming a crystalline semiconductor film on an insulating
 surface;

CERTIFICATE OF TRANSMISSION BY FACSIMILE

I hereby certify that this correspondence is being transmitted by
 facsimile to the Patent and Trademark Office on the date indicated
 below.

Date of Transmission

September 23, 2002

Signature

Susan Regan

Susan Regan
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